



IFW

UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of: **HAYASHI, Nobuhiko**

Group Art Unit: **2828**

Serial No.: **09/532,786**

Examiner: **Armando RODRIGUEZ**

Filed: **March 22, 2000**

**P.T.O. Confirmation No.: 8588**

FOR: **SEMICONDUCTOR LASER DEVICE AND METHOD OF FABRICATING THE SAME**

**AMENDMENT UNDER 37 CFR §1.111**

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

**December 23, 2005**

Sir:

In response to the Office Action dated **October 11, 2005**, please amend the above-identified application as follows:

**Amendments to the Claims** are reflected in the listing of claims which begins on page 2 of this paper.

**Remarks/Arguments** begin on page 10 of this paper.